

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hiroto OHTAKE, et al.

Appln. No.:

10/080,848

: Art Unit: 1765

Filed:

February 22, 2002

Examiner: DEO, Duy Vu Nguyen

For:

**METHOD OF MANUFACTURING A** : Docket No.:

KRM-00101

SEMICONDUCTOR DEVICE

CAPABLE OF ETCHING A MULTI-

LAYER OF ORGANIC FILMS AT A

HIGH SELECTIVITY

## **CERTIFICATE OF MAILING**

I hereby certify that the foregoing document is being deposited with the United States Postal Service as first class mail, postage prepaid, "Post Office to Addressee", in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22343-1450 on April 8, 2904.

## RESPONSE TO ELECTION/RESTRICTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 16, 2004, in which election of species was required, Applicant elects Group II, Claims 20-29 that are drawn to a product.

Favorable consideration and allowance are earnestly solicited. Should there be any questions after reviewing this paper, the Examiner is invited to contact the undersigned at 617-248-4038.

Respectfully submitted,

CHOATE/HALL &STEWAR

Date: April 8, 2004

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